- -- FIEUCIVEU CENTRAL PAX CENTER

AUG 1 0 2005

Certificate of Facsimile Transmission

I hereby certify that the attached Transmittal (1 page), Amendment After Allowance Response to the Notice of Allowance dated May 11, 2005 (5 pages) are submitted to the U.S. Patent and Trademark Office via facsimile number (571) 273-83000n the date shown below. (Total 9 pages).

Li Mei Vermilya

Date: August 10, 2005

PATENT APPLICATION Do. No. 4591-383 Client No. IE10112-US-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

You-Cheol SHINget al.

Serial No.:

10/777,233

Examiner:

Brewster, William M.

Filed:

February 11, 2004

Group Art Unit: 2823

For:

SEMICONDUCTOR DEVICE AND METHOD OF

MANUFACTURING THE SAME INCLUDING FORMING METAL

SILICIDE GATE LINES AND SOURCE LINES (as amended)

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Responsive to the Notice of Allowance dated May 11, 2005, enclosed is an amendment in the above-identified application.

The fee has been calculated as shown below.

For: Number After Amendment Previous Data								1 A 1 1 2 2 2 2 1 17 2
Total Claims 5 5 0 x \$50 = \$0	For:		1	Extra	Rate			Additional Fe
2 0 x \$200 = \$0	Total Claims	5	5	0	x	\$50	-	\$0
Independent Claims	Independent Claims	2	2	0	х	\$200	=	\$0

^{*}greater of twenty (20) or number for which fee has been paid

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Customer No. 20575

Respectfully submitted, MARGER JOHNSON & McCOLLOM, Y.C.

Hosoon Lee, Reg. No. 56,737

MARGER JOHNSON & McCOLLOM, P.C. 210 SW Morrison Street, Suite 400 Portland, OR 97204 (503) 222-3613

^{**}greater of three (3) or number for which fee has been paid

RECEIVED
CENTRAL FAX CENTER
AUG 1 0 2005

PATENT APPLICATION Do. No. 4591-383 Client No. IE10112-US-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

You-Cheol SHIN, et al.

Serial No.:

10/777,233

Examiner:

Brewster, William M.

Filed:

February 11, 2004

Group Art Unit:

2823

For:

SEMICONDUCTOR DEVICE AND METHOD OF

MANUFACTURING THE SAME INCLUDING FORMING METAL

SILICIDE GATE LINES AND SOURCE LINES (as amended)

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312

Responsive to the Notice of Allowance, dated May 11, 2005, please amend the application as follows.